

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Kunihiko SAKURAI et al. :
Serial No. NEW : **Attn: APPLICATION BRANCH**
Filed January 5, 2004 : Attorney Docket No. 2003-1770

POLISHING APPARATUS
(Rule 1.53(b) Divisional
of Serial No. 10/026,763,
Filed December 27, 2001)

CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

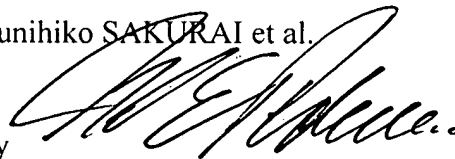
Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 11-59522, filed March 5, 1999, and Japanese Patent Application No. 11-233983, filed August 20, 1999, as acknowledged in the Declaration of this application.

Certified copies of said Japanese Patent Application are of record in parent application Serial No. 10/026,763, filed December 27, 2001.

Respectfully submitted,

Kunihiko SAKURAI et al.

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